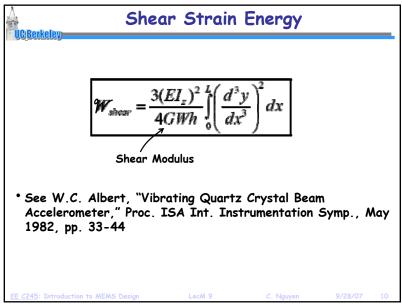
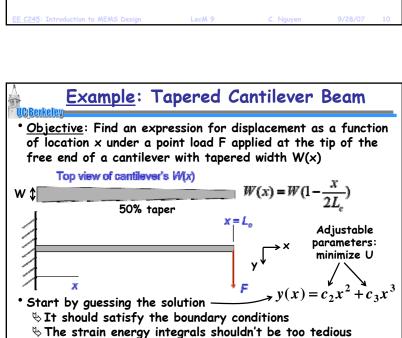
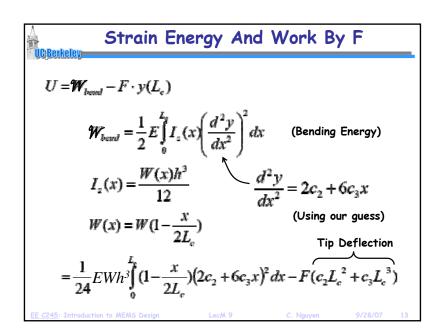
EE 245: Introduction to MEMS Lecture 18m1: Energy Methods





This might not matter much these days, though, since

Applying the Principle of Virtual Work "Basic Procedure: Guess the form of the beam deflection under the applied loads Vary the parameters in the beam deflection function in order to minimize: $U = \sum_{j} W_{j} - \sum_{i} F_{i} u_{i}$ Displacement at point load Find minima by simply setting derivatives to zero See Senturia, pg. 244, for a general expression with distrubuted surface loads and body forces



one could just use matlab or mathematica

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Find c_2 and c_3 That Minimize U

- Minimize $U \rightarrow$ basically, find the c_2 and c_3 that brings U closest to zero (which is what it would be if we had guessed correctly)
- The c_2 and c_3 that minimize U are the ones for which the partial derivatives of U with respective to them are zero:

$$\frac{\partial U}{\partial c_2} = 0 \qquad \frac{\partial U}{\partial c_3} = 0$$

• Proceed:

♦ First, evaluate the integral to get an expression for U:

$$U = EWh^{3} \left\{ \frac{5c_{3}^{2}}{16} L_{e}^{3} + \frac{c_{2}c_{3}}{3} L_{e}^{2} + \frac{c_{2}^{2}}{8} L_{e} \right\} - F(c_{2}L_{e}^{2} + c_{3}L_{e}^{3})$$

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Minimize U (cont)

• Evaluate the derivatives and set to zero:

$$\frac{\partial U}{\partial c_2} = 0 = \left(\frac{EWh^3}{3}c_3 - F\right)L_e^2 + \left(\frac{EWh^3}{4}c_2\right)L_e$$

$$\frac{\partial U}{\partial c_3} = 0 = \left(\frac{5}{8}EWh^3c_3 - F\right)L_e^3 + \left(\frac{EWh^3}{3}c_2\right)L_e^2$$

• Solve the simultaneous equations to get c_2 and c_3 :

$$c_2 = \left(\frac{84}{13}\right) \frac{FL_e}{EWh^3}$$
 $c_3 = -\left(\frac{24}{13}\right) \frac{F}{EWh^3}$

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The Virtual Work-Derived Solution

· And the solution:

$$y(x) = \left(\frac{24F}{13EWh^3}\right) \left(\frac{7}{2}\right) L_o - x x^2$$

• Solve for tip deflection and obtain the spring constant:

$$y(L_e) = \left(\frac{24F}{13EWh^3}\right)\left(\frac{5}{2}\right)L_e^3$$
 $k_e = F/y(L_e) = \left(\frac{13EWh^3}{60L_e^3}\right)$

 Compare with previous solution for constant-width cantilever beam (using Euler theory):

$$y(L_e) = \left(\frac{4F}{EWh^3}\right) L_e^3 \longrightarrow 13\%$$
 smaller than tapered-width case

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Comparison With Finite Element Simulation

*Below: ANSYS finite element model with

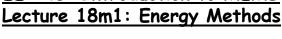
L = 500 μm W_{base} = 20 μm E = 170 GPa

h = 2 μm W_{tip} = 10 μm

*Result: (from static analysis)

\$\frac{1}{2} \text{k} \text{k} = 0.471 μN/m}\$

*This matches the result from energy minimization to 3 significant figures



Need a Better Approximation?

- Add more terms to the polynomial
- Add other strain energy terms:
 - ♦ Shear: more significant as the beam gets shorter
 - & Axial: more significant as deflections become larger
- Both of the above remedies make the math more complex, so encourage the use of math software, such as Mathematica, Matlab, or Maple
- Finite element analysis is really just energy minimization
- If this is the case, then why ever use energy minimization analytically (i.e., by hand)?
 - Analytical expressions, even approximate ones, give insight into parameter dependencies that FEA cannot
- Scan compare the importance of different terms
- Should use in tandem with FEA for design

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